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UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/420,635
Filing Date October 21, 1999
Inventor Werner Juengling
Assignee Micron Technology, Inc.
Group Art Unit 2812
Examiner H. Tsai
Attorney's Docket No. MI22-1243
Title: Semiconductor Processing Methods of Forming Devices on a Substrate, Forming Device Arrays on a Substrate, Forming Conductive Lines on a Substrate, and Forming Capacitor Arrays on a Substrate, and Integrated Circuitry

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the references listed on the attached Form PTO-1449. No admission is made regarding whether the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,



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Date: Apr. 11, 2002

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